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MEMS Adaptive Optics IV

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Editors

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Contents

- vii *Conference Committee*
- ix *Emerging research in micro and nano systems: opportunities and challenges for societal impact (Plenary Paper) [7593-201]*
Y. B. Gianchandani, Univ. of Michigan (United States)
- xvii *MEMS technologies for artificial retinas (Plenary Paper) [7594-202]*
W. Mokwa, RWTH Aachen Univ. (Germany)

MOEMS-MEMS PLENARY SESSION

- 7595 02 **Shaping light: MOEMS deformable mirrors for microscopes and telescopes (Plenary Paper)** [7595-203]
T. Bifano, Boston Univ. Photonics Ctr. (United States)

SESSION 1 MEMS AO FOR LASERS AND COMMUNICATION

- 7595 05 **Low power MEMS modulating retroreflectors for optical communication (Invited Paper)** [7595-03]
J. B. Stewart, Boston Micromachines Corp. (United States); D. Freedman, Boston Univ. (United States); S. Cornelissen, Boston Micromachines Corp. (United States); M. N. Horenstein, Boston Univ. (United States); P. Woskov, Boston Micromachines Corp. (United States); J. Tang, Boston Univ. (United States)
- 7595 06 **High-power visible-laser effect on a 37-segment Iris AO deformable mirror** [7595-04]
A. Norton, D. Gavel, D. Dillon, Univ. of California Observatories (United States)
- 7595 07 **Fast autonomous holographic adaptive optics** [7595-05]
G. Andersen, U.S. Air Force Academy (United States)

SESSION 2 MEMS AO FOR ASTRONOMY

- 7595 08 **Progress update on the visible light laser guidestar experiments at Lick Observatory (Invited Paper)** [7595-06]
D. T. Gavel, Univ. of California Observatories (United States)
- 7595 09 **Analysis of the Naval Research Laboratory MEM MCAO test bed (Invited Paper)** [7595-07]
S. R. Restaino, J. R. Andrews, T. Martinez, C. C. Wilcox, F. Santiago, Naval Research Lab. (United States); D. M. Payne, Narrascope, Inc. (United States); S. W. Teare, New Mexico Institute of Mining and Technology (United States)

- 7595 0A **Using two MEMS deformable mirrors in an adaptive optics test bed for multiconjugate correction (Invited Paper)** [7595-08]
J. R. Andrews, T. Martinez, Naval Research Lab. (United States); S. W. Teare, New Mexico Institute of Mining and Technology (United States); S. R. Restaino, C. C. Wilcox, F. Santiago, Naval Research Lab. (United States); D. M. Payne, Narrascope, Inc. (United States)
- 7595 0B **Reliability of MEMS deformable mirror technology used in adaptive optics imaging systems (Invited Paper)** [7595-09]
A. L. Hartzell, S. A. Cornelissen, P. A. Bierden, C. V. Lam, D. F. Davis, Boston Micromachines Corp. (United States)
- 7595 0C **Preliminary results of large-actuator-count MEMS DM development** [7595-10]
M. A. Helmbrecht, M. He, P. Rhodes, C. J. Kempf, Iris AO, Inc. (United States)
- 7595 0D **Open loop control on large stroke MEMS deformable mirrors** [7595-11]
A. Diouf, T. G. Bifano, A. P. Legendre, Y. Lu, Boston Univ. Photonics Ctr. (United States); J. B. Stewart, Boston Micromachines Corp. (United States)
- 7595 0E **Modeling, parameter estimation, and open-loop control of MEMS deformable mirrors** [7595-12]
C. R. Vogel, Montana State Univ. (United States); G. A. Tyler, The Optical Sciences Co. (United States); Y. Lu, Boston Univ. (United States)

SESSION 3 MEMS AO FOR BIO-IMAGING

- 7595 0F **Adaptive optics for microscopy and photonic fabrication (Invited Paper)** [7595-13]
A. Jesacher, A. Thayil, T. Wilson, M. J. Booth, Univ. of Oxford (United Kingdom)
- 7595 0G **Adaptive optics multiphoton microscopy (Invited Paper)** [7595-14]
E. J. Gualda, J. M. Bueno, P. Artal, Univ. de Murcia (Spain)
- 7595 0H **Double side membrane deformable mirror for pulse shaping** [7595-15]
S. Bonora, CNR-INFM (Italy), Univ. degli Studi di Padova (Italy) and Politecnico di Milano (Italy); D. Brida, C. Manzoni, S. De Silvestri, Politecnico di Milano (Italy) and CNR-INFM (Italy); P. Villoresi, CNR-INFM (Italy) and Univ. degli Studi di Padova (Italy); G. Cerullo, Politecnico di Milano (Italy) and CNR-INFM (Italy)
- 7595 0I **Implementation of adaptive optics in fluorescent microscopy using wavefront sensing and correction** [7595-16]
O. Azucena, J. Crest, J. Cao, W. Sullivan, Univ. of California, Santa Cruz (United States); P. Kner, Univ. of California, San Francisco (United States); D. Gavel, D. Dillon, Univ. of California Observatories (United States); S. Olivier, Lawrence Livermore National Lab. (United States); J. Kubby, Univ. of California, Santa Cruz (United States)

- 7595 OJ **New results of unimorph laser mirrors with screen printed actuator** [7595-17]
C. Bruchmann, T. Burkhardt, Friedrich-Schiller-Univ. Jena (Germany) and Fraunhofer Institute for Applied Optics and Precision Engineering (Germany); A. Kamm, Fraunhofer Institute for Applied Optics and Precision Engineering (Germany); S. Gebhardt, Fraunhofer Institute for Ceramic Technologies and Systems (Germany); E. Beckert, R. Eberhardt, Fraunhofer Institute for Applied Optics and Precision Engineering (Germany); A. Tünnermann, Friedrich-Schiller-Univ. Jena (Germany) and Fraunhofer Institute for Applied Optics and Precision Engineering (Germany)

SESSION 4 MEMS AO DEVICES

- 7595 OM **Adaptive optics control system for segmented MEMS deformable mirrors** [7595-20]
C. J. Kempf, M. A. Helmbrecht, M. Besse, Iris AO, Inc. (United States)
- 7595 ON **Through-wafer interconnects for high degree of freedom MEMS deformable mirrors** [7595-21]
A. Diouf, T. G. Bifano, Boston Univ. Photonics Ctr. (United States); J. B. Stewart, S. Cornelissen, P. Bierden, Boston Micromachines Corp. (United States)
- 7595 OP **Pseudo-analog electrostatic piston micromirror** [7595-23]
H. Gu, G. Sivakumar, T. Dallas, Texas Tech Univ. (United States)
- 7595 OQ **Hi-speed compact deformable mirror: status, applications, and perspectives** [7595-24]
F. Rooms, S. Camet, J.-F. Curis, ALPAO (France)
- 7595 OR **Optically addressable deformable membrane mirror** [7595-25]
S. Bonora, CNR-INFN (Italy) and Univ. degli Studi di Padova (Italy); U. Bortolozzo, INLN, CNRS, Univ. de Nice Sophia-Antipolis (France); J. P. Huignard, Thales Research & Technology (France); S. Residori, INLN, CNRS, Univ. de Nice Sophia-Antipolis (France)

Author Index

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